IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Eiichi NAGATSUKA et al.

Serial No.: Currently unknown

Filing Date: Concurrently herewith

For: RESISTANCE WELDING METHOD AND STRUCTURE OF RESISTANCE WELDING PART, AND METHOD FOR MANUFACTURING

ELECTRONIC COMPONENT AND ELECTRONIC COMPONENT

Parent Appln. Serial No.: 09/652,953

Parent Filing Date: August 31, 2000

INFORMATION DISCLOSURE STATEMENT

U.S. Patent and Trademark Office 2011 South Clark Place Customer Window, Mail Stop PATENT APPLICATION Crystal Plaza Two, Lobby, Room 1B03 Arlington, VA 22202

Sir:

In accordance with 37 CFR §1.56, and in recognition of their duty to disclose to the United States Patent and Trademark Office relevant information known to be material to patentability, Applicants herewith submit herewith an Information Disclosure Statement (Form PTO-1449), which lists all the prior art references that were listed in the Parent Application No. 09/652,953, currently pending. Accordingly, a copy of these references can be found in the Parent Application No. 09/652,953, currently pending. The statement is not a representation that all of the information cited is necessarily effective as prior art against the application.

Information Disclosure Statement November 14, 2003 Page 2 of 2

Applicants respectfully request that the disclosed references be made of record in the subject application.

Respectfully submitted,

Date: November 14, 2003

Attorneys for Applicant(s)

Joseph R. Keating Registration No. 37,368

Christopher A. Bennett Registration No. 46,710

KEATING & BENNETT LLP 10400 Eaton Place, Suite 312 Fairfax, VA 22030

Telephone: (703) 385-5200

Substitute for form 1449/PTO

INFORMATION DISCLOSURE

STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1 of 1

Complete if Known

Application Number

Filing Date

First Named Inventor

Eiichi NAGATSUKA

Art Unit

Examiner Name

Attorney Docket Number 36856.1170

U.S. PATENT DOCUMENTS									
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ^{2(if known)}	Publication Date MM -YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear				
	1	3,919,519	11/1975	Petersen					
	2	4,772,823	09/1988	Matsuzaki et al.					
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FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ³ Number-Kind Code ⁵ (if known)	Publication Date MM -YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Le		
	3	JP 7-3128	01/1995			X		
	4	JP 5-28751	07/1993			X		
	5	JP 3-258467	11/1991			Х		
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Examiner	Date	
Signature	Considered	

^{*}Examiner: Initial if reference considered, whether of not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered, include copy of this form with next communication to applicant.

¹ Applicant unique citation designation number (optional). ²See Kind Codes of USPTO Patent documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document by the two-letter code (WIPO Strandard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Abstract is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14.